IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Fernando Gonzalez et al.

Title: METHOD TO CHEMICALLY REMOVE METAL IMPURITIES FROM POLYCIDE GATE

SIDEWALLS

Docket No.: 303,775US1

US1 Serial No.: 09/945,553

Filed: August 30, 2001 Due Date: February 13, 2008

Examiner: George Fourson Group Art Unit: 2823
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Mail Stop Issue Fee

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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